DEC 0 1 2005

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Lee et al.

Application No.: 09/888,084

Confirmation No.: 8101

Filed: June 21, 2001

Art Unit: 3723

For: METHODS AND APPARATUS FOR

ELECTRICAL, MECHANICAL AND/OR

CHEMICAL REMOVAL OF CONDUCTIVE

MATERIAL FROM A

MICROELECTRONIC SUBSTRATE

Examiner: D. V. Nguyen

INFORMATION DISCLOSURE STATEMENT (IDS)

MS RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is filed concurrently with the filing of a Request for Continued Examination under 37 CFR 1.114 (37 CFR 1.97(b)(4)).

An English language translation of the abstract of the non-US Patent reference is enclosed.

Application No.: 09/888,084 Docket No.: 108298515US1

Applicant has not submitted copies of each cited U.S. patent and U.S. patent application as required by 37 CFR 1.98(a)(2)(i), amended October 2004, as the U.S. Patent and Trademark Office has waived this requirement for all U.S. patent applications. Applicant submits herewith copies of foreign and non-patents in accordance with 37 CFR

1.98(a)(2).

In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. In accordance with 37 CFR 1.97(h), the filing of this Information Disclosure statement shall not be construed to be an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 50-0665, under Order No. 108298515US1.

Dated: December 1, 2005

Respectfully submitted,

John M. Wechkin

Registration No.: 42,216

PERKINS COIE LLP

P.O. Box 1247

Seattle, Washington 98111-1247

(206) 359-8000

(206) 359-7198 (Fax)

Attorneys for Applicant



Express Mail No. EV758928328US



Attorney Docket No. 108298515US1 Disclosure No. 00-0998.00/US

PTO/SB/08a/b (07-05)

Approved for use through 07/31/2006. OMB 0651-0031
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Substitute for form 1449A/B/PTO				Complete if Known		
				Application Number	09/888,084-Conf. #8101	
INFORMATION DISCLOSURE				Filing Date	June 21, 2001	
STATEMENT BY APPLICANT			PLICANT	First Named Inventor	Whonchee Lee	
				Art Unit	3723	
	(Use as many sheets as necessary)			Examiner Name	D. V. Nguyen	
Sheet	1	of	1	Attorney Docket Number	108298515US1	

	U.S. PATENT DOCUMENTS						
Examiner	Cite	Document Number	Publication Date	Traine or ratemos or	Pages, Columns, Lines, Where Relevant Passages or Relevant		
Initials*	No.1	Number-Kind Code ² (if known) MI	IVIIVI-DD-1111	Applicant of Cited Document	Figures Appear		
		US-6,416,647	07-09-2002	Dordi et al.			
		US-3,239,439	03-08-1966	Helmke			
		US-6,693,036-B1	02-17-2004	Nogami et al.			

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Foreign Patent Document Country Code³-Number⁴-Kind Code⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T⁵
		JP-1-241129-A	09-26-1989	Toshiba Corp.		

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. * CITE NO.: Those application(s) which are marked with an single asterisk (*) next to the Cite No. are not supplied (under 37 CFR 1.98(a)(2)(iii)) because that application was filed after June 30, 2003 or is available in the IFW. 'Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Examiner	Date	
Signature	Considered	
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¹Applicant's unique citation designation number (optional). ²Applicant is to place a check mark here if English language Translation is attached.